

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: )  
Shinji MAEKAWA et al. ) Confirmation No. 3788  
Application No. 10/575,492 ) Examiner: Stanetta D. Isaac  
Filed: April 12, 2006 ) Group Art Unit: 2812  
For: METHOD FOR FORMING WIRING, METHOD )  
FOR MANUFACTURING THIN FILM )  
TRANSISTOR AND DROPLET DISCHARGING ) Date: February 3, 2009  
METHOD )

**INFORMATION DISCLOSURE STATEMENT**

**Mail Stop: RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return it to the undersigned.

The Commissioner is hereby authorized to charge the requisite \$180 fee in order to comply with the provisions of 37 C.F.R. § 1.97(c), and any other fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

**NIXON PEABODY, LLP**

Date: February 3, 2009

/Anthony Canning, Reg. #62,107/

Anthony Canning

Registration No. 62,107

**NIXON PEABODY LLP**

**Customer No.: 22204**

401 9th Street, N.W., Suite 900

Washington, DC 20004

Tel: 202-585-8000

Fax: 202-585-8080